

Magnetic Force Microscopy

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Systems and Materials for Information storage

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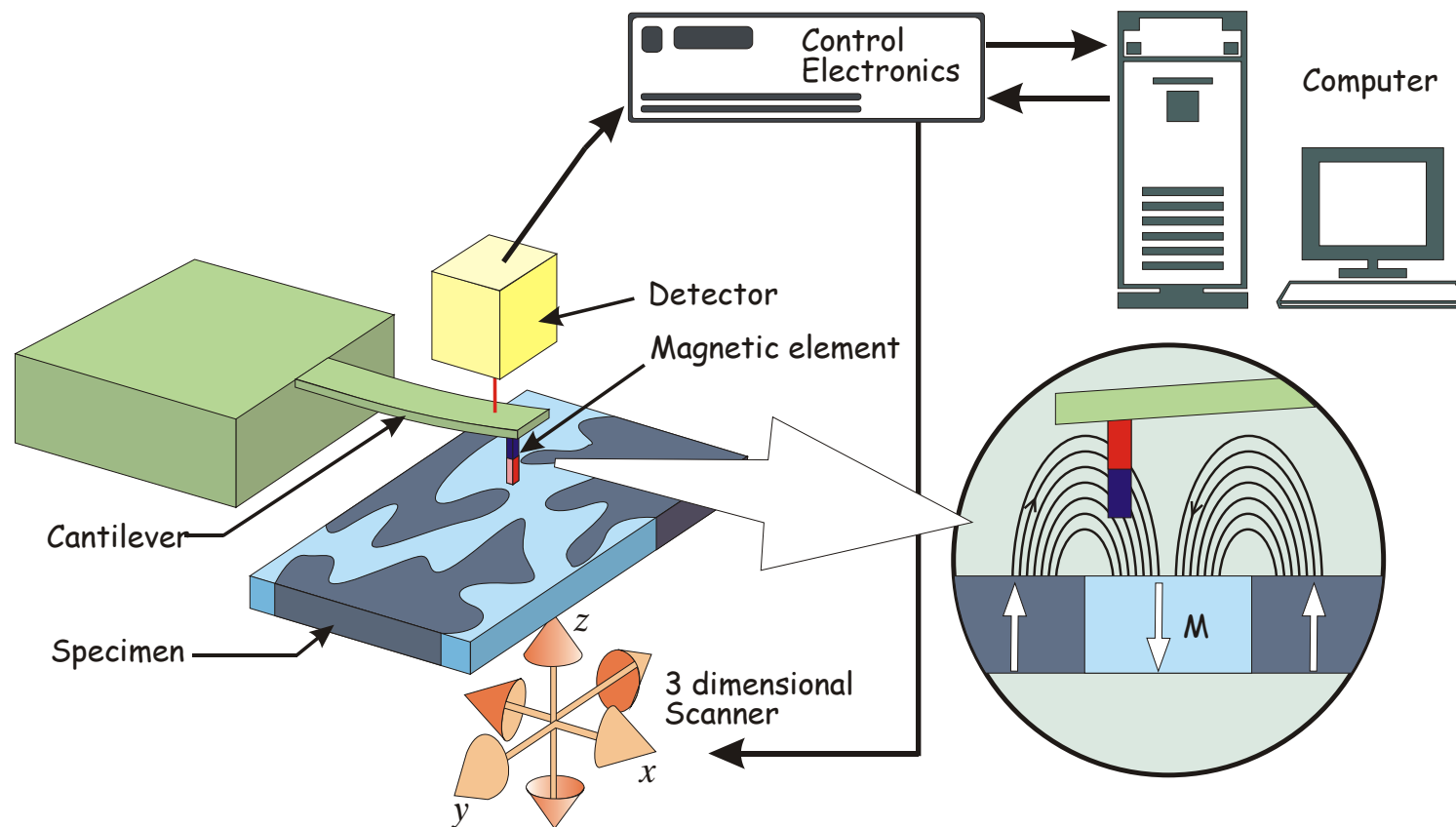
Systems and Materials for Information storage

Constanta Summerschool, Sep 2005 (September 14, 2005)

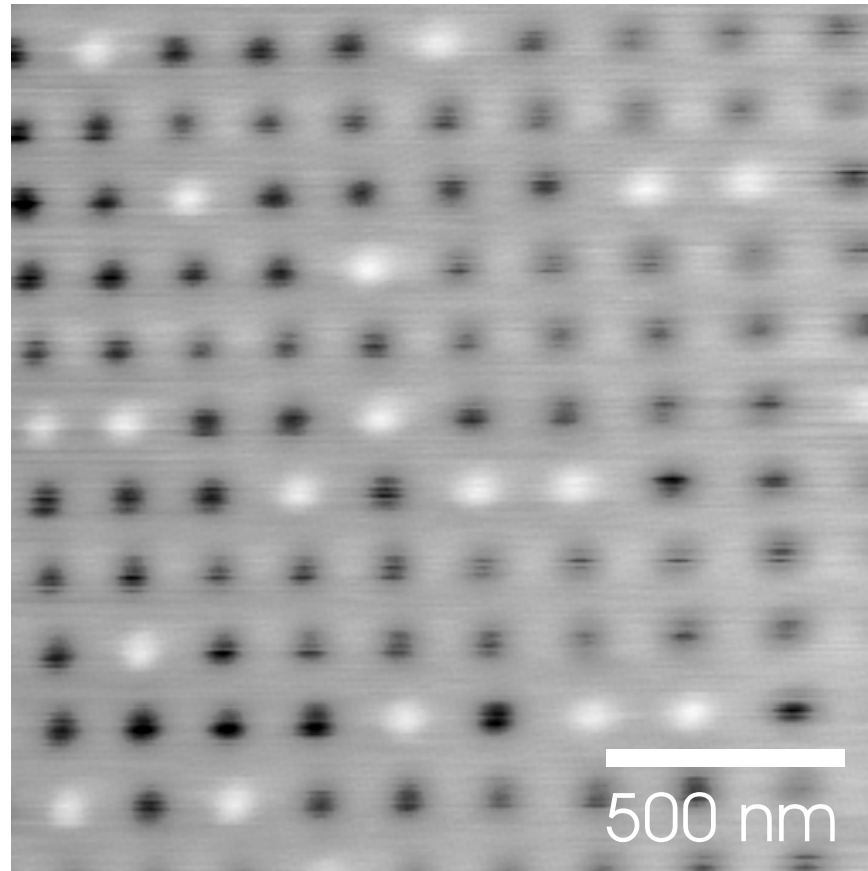
Contents

- Before break: MFM Operation
 - Principle of MFM
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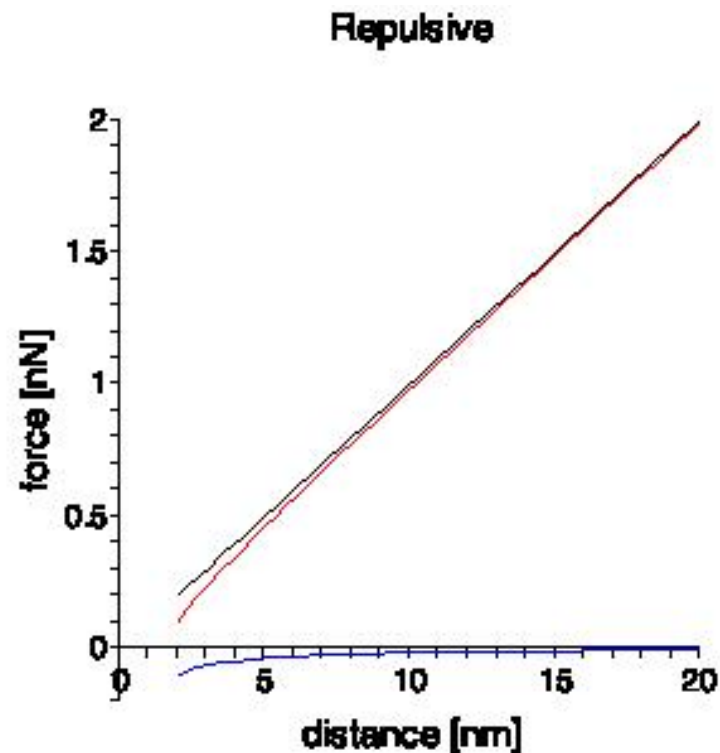
Principle of MFM



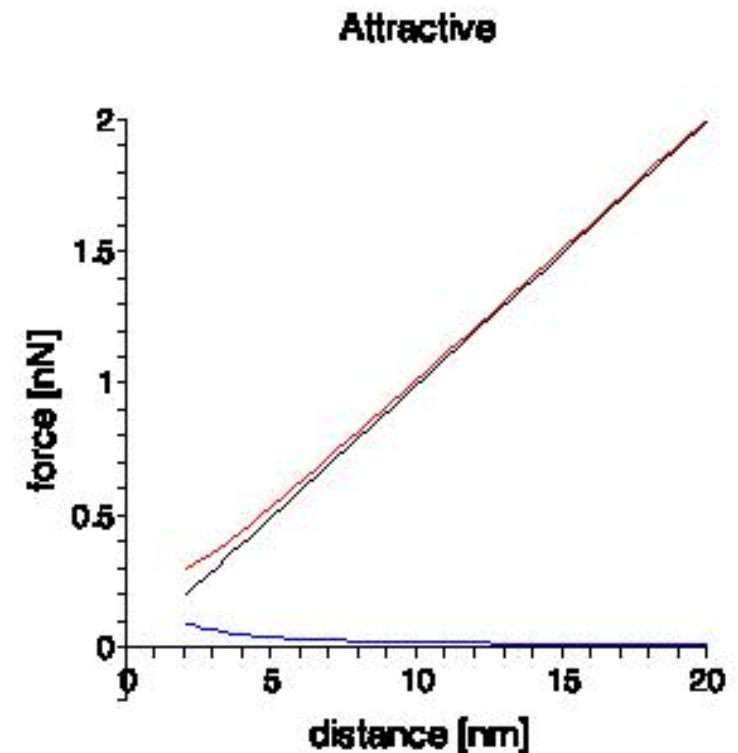
Magnetic Force Microscopy



Change in resonance



— cantilever
— magnetic force
— combination



— cantilever
— magnetic force
— combination

Amplitude, Phase, Frequency

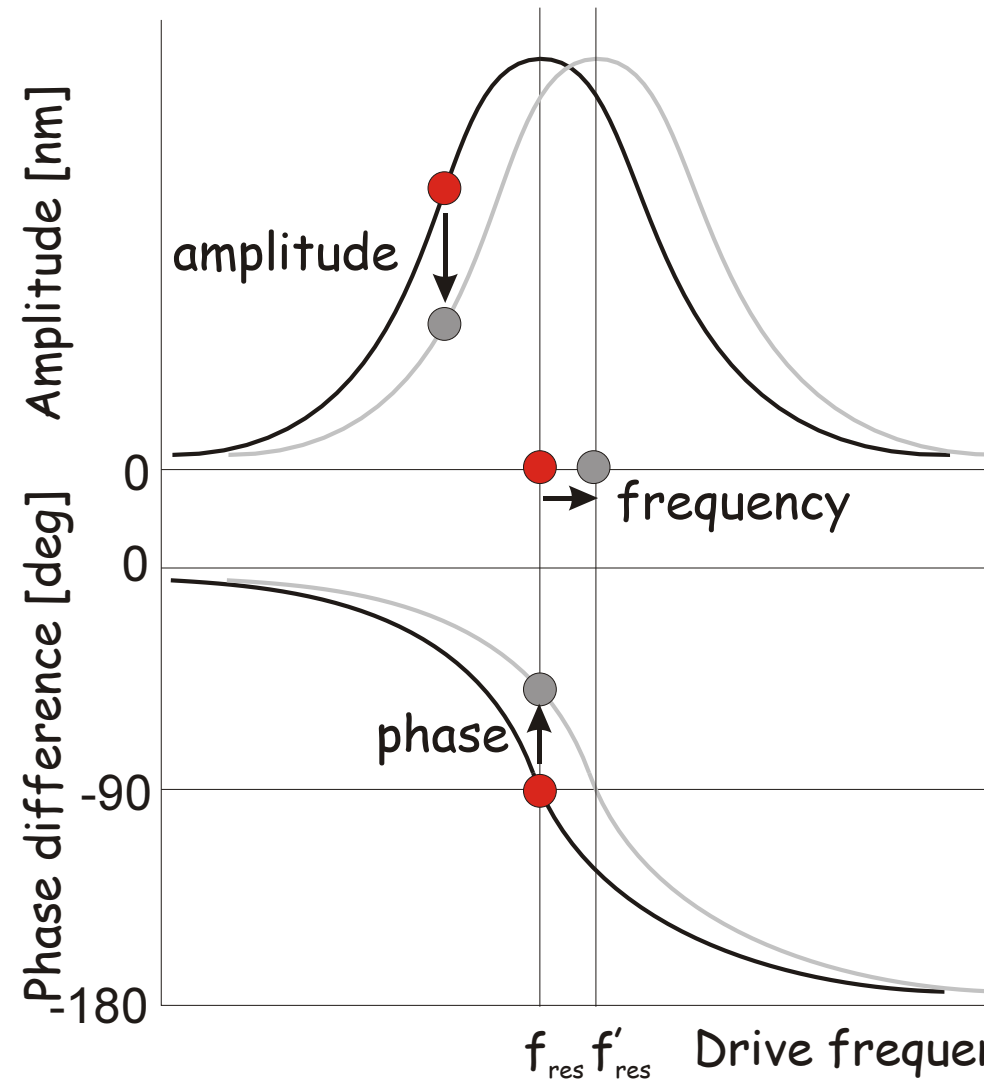


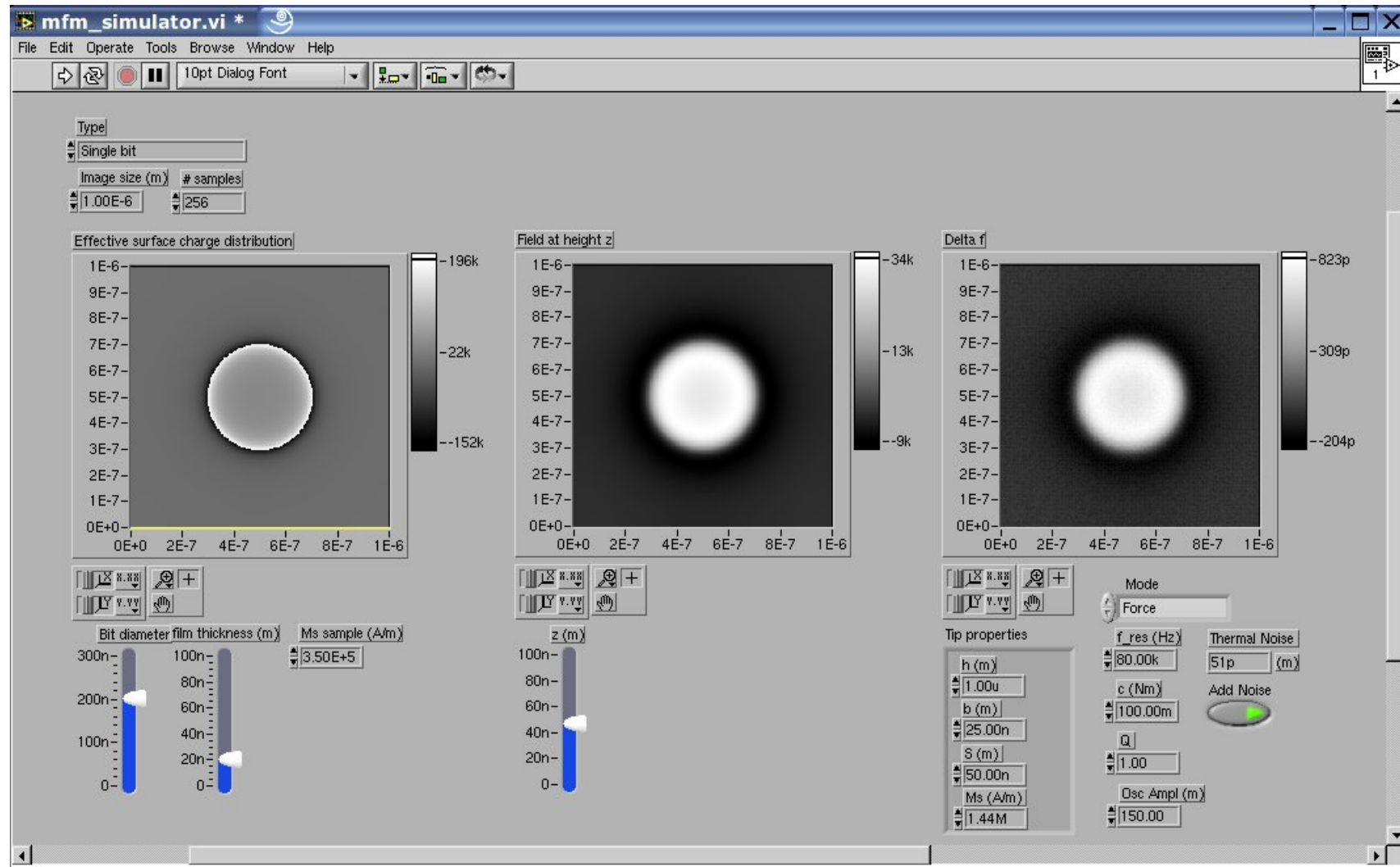
Image formation

Transform stray field to Fourier space:

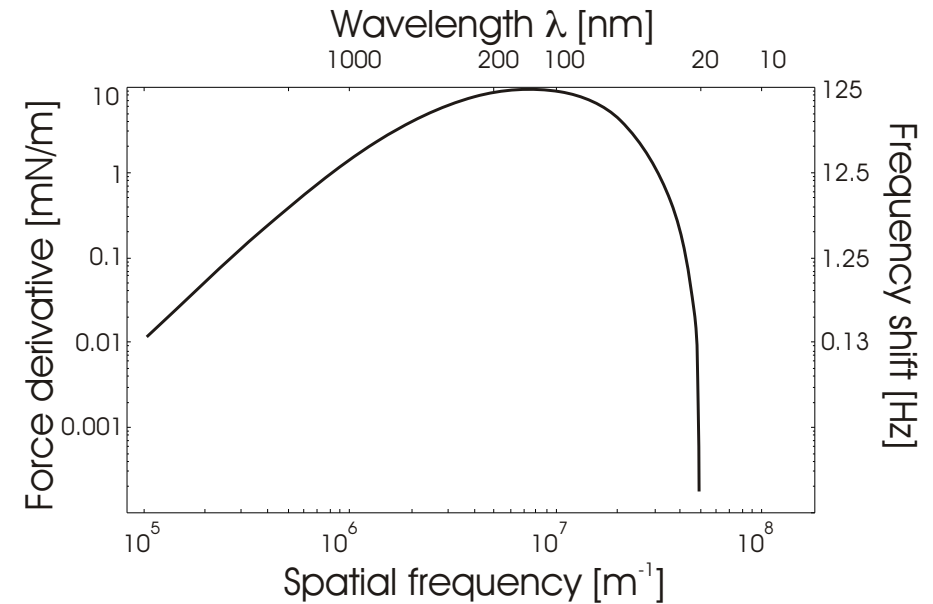
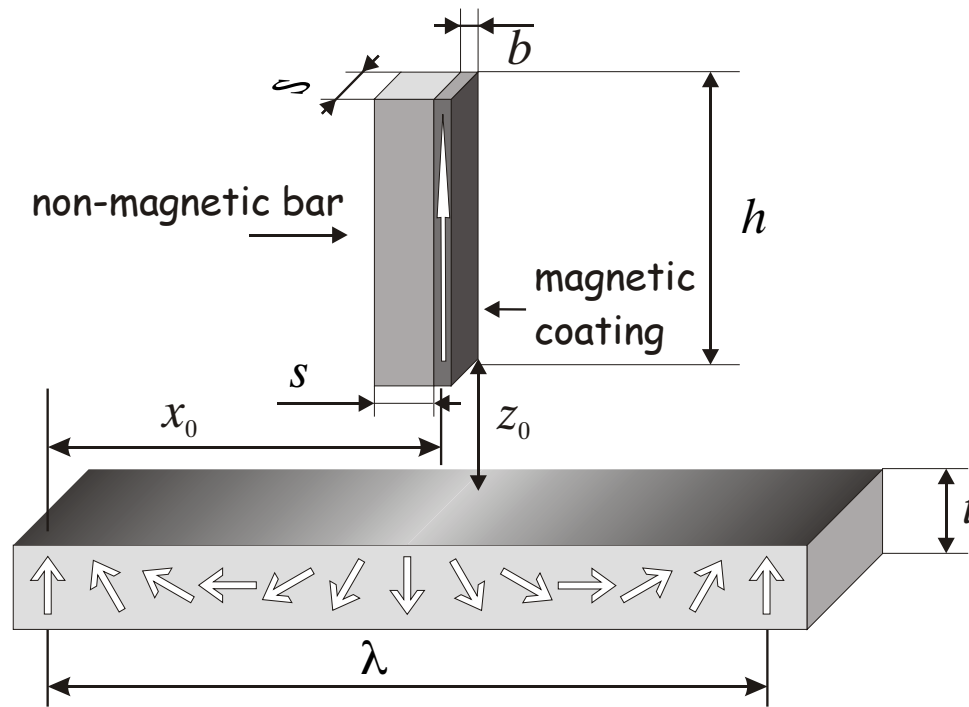
$$\widehat{\mathbf{H}}(k_x, k_y, z) = \int_{-\infty}^{\infty} \int_{-\infty}^{\infty} \mathbf{H}(x, y, z) e^{-i(xk_x + yk_y)} dx dy$$

$$\widehat{\mathbf{H}}(k_x, k_y, z) = \exp(-|\mathbf{k}|z) \cdot \widehat{\mathbf{H}}(k_x, k_y, 0)$$

MFM Demonstrator

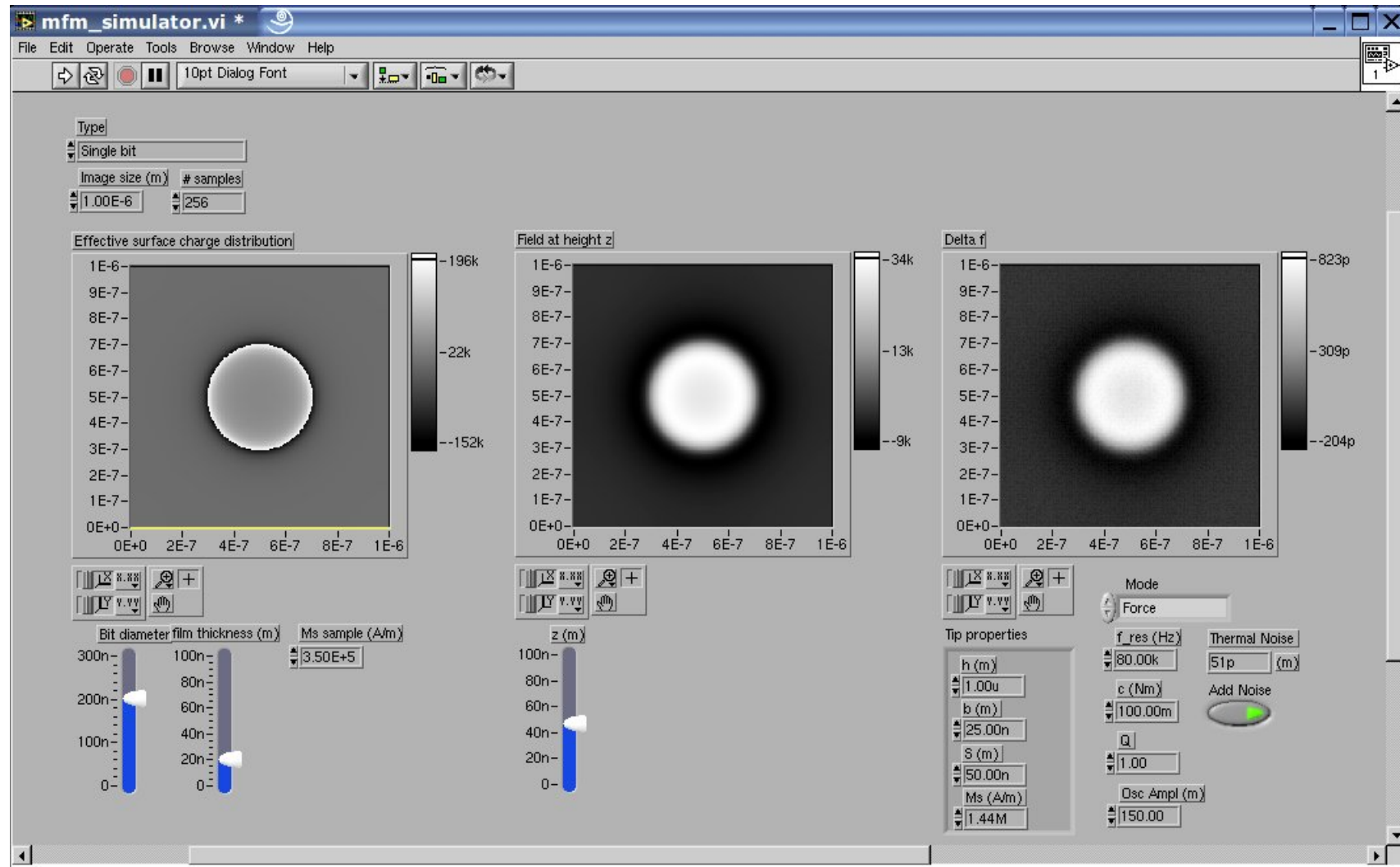


Tip transfer function

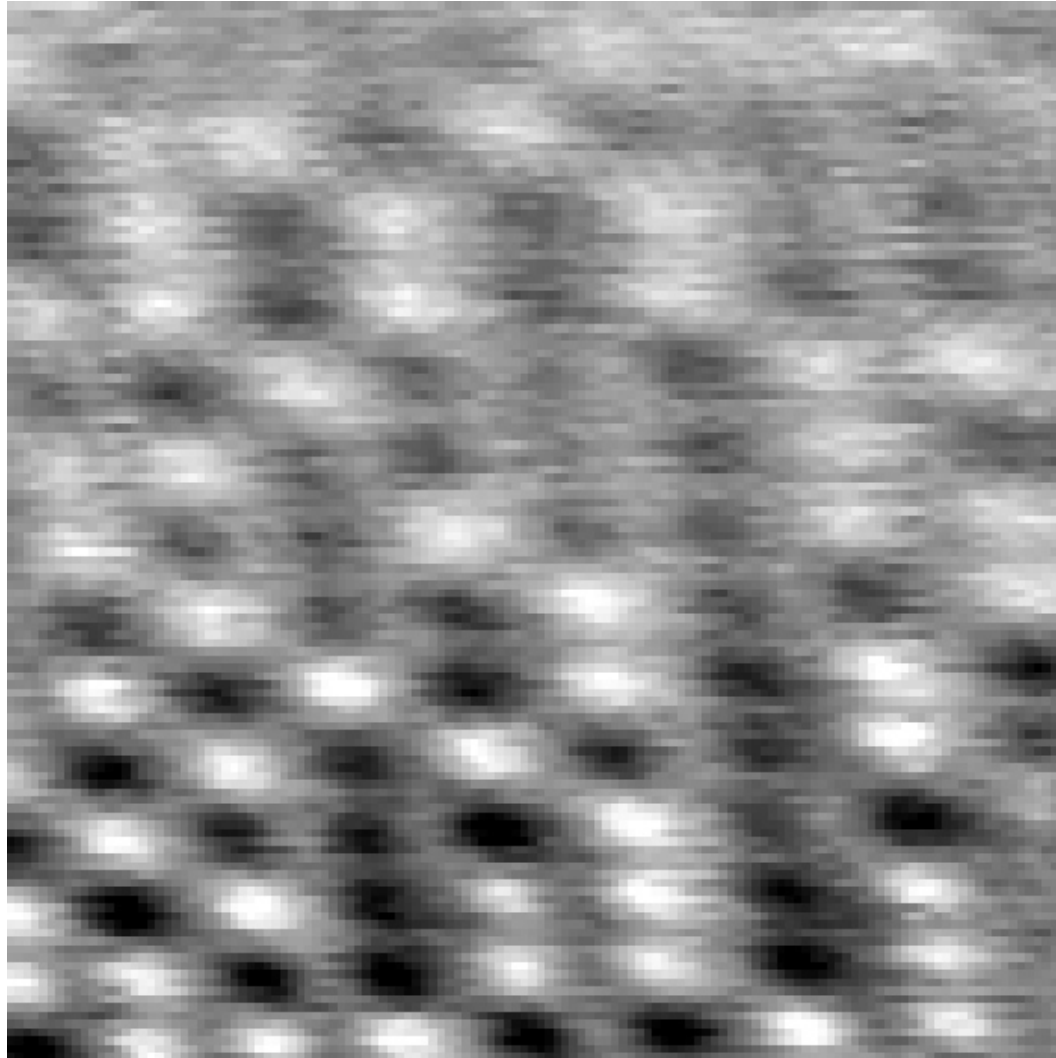


$$\hat{F}_z(\mathbf{k}, z) = -\mu_0 M_t \cdot b \operatorname{sinc}\left(\frac{k_x b}{2}\right) \cdot S \operatorname{sinc}\left(\frac{k_y S}{2}\right) \cdot \hat{\mathbf{H}}(\mathbf{k}, z)$$

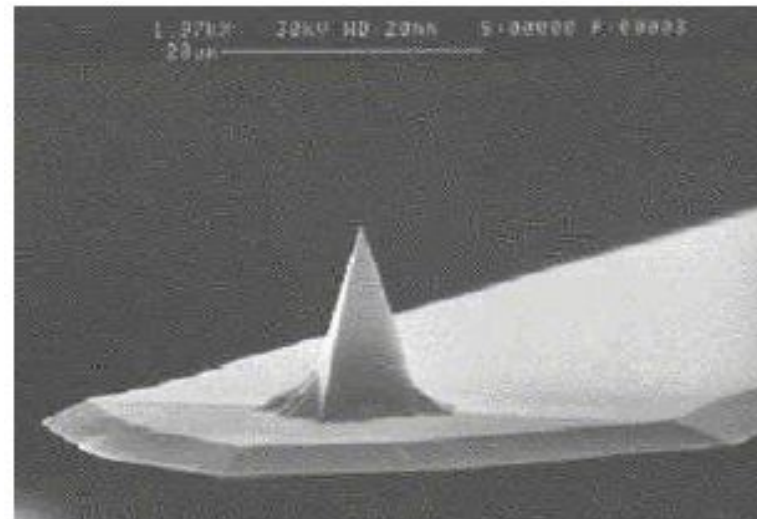
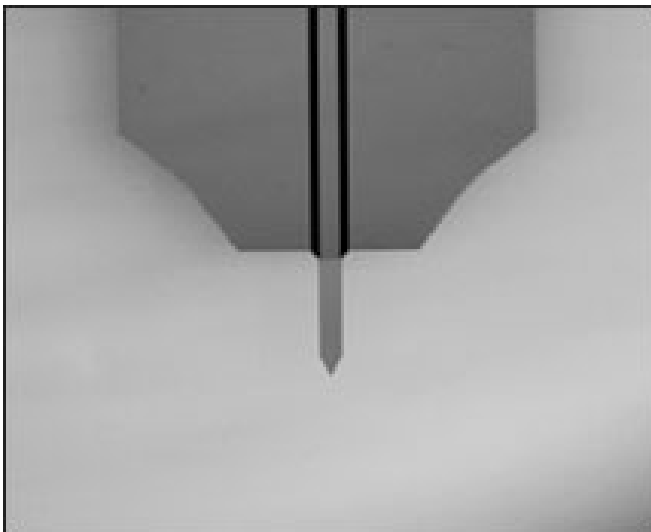
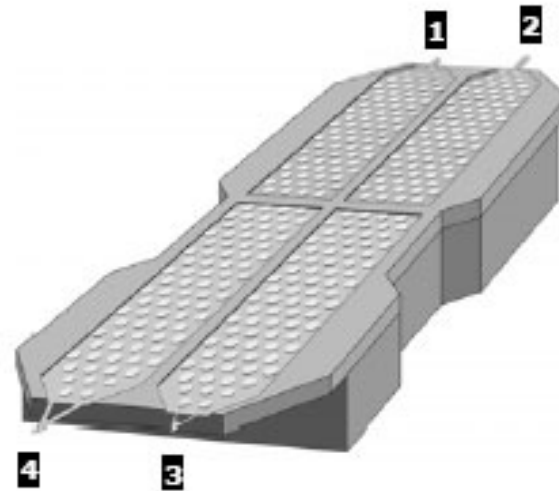
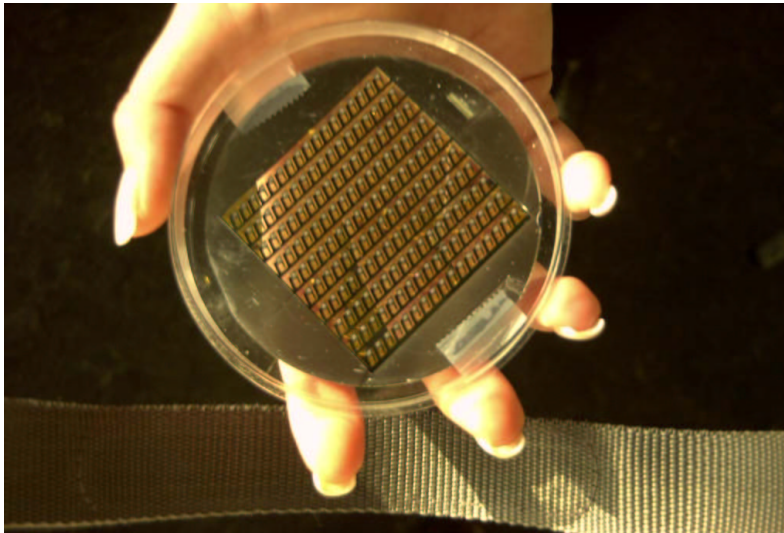
MFM Demonstrator 2



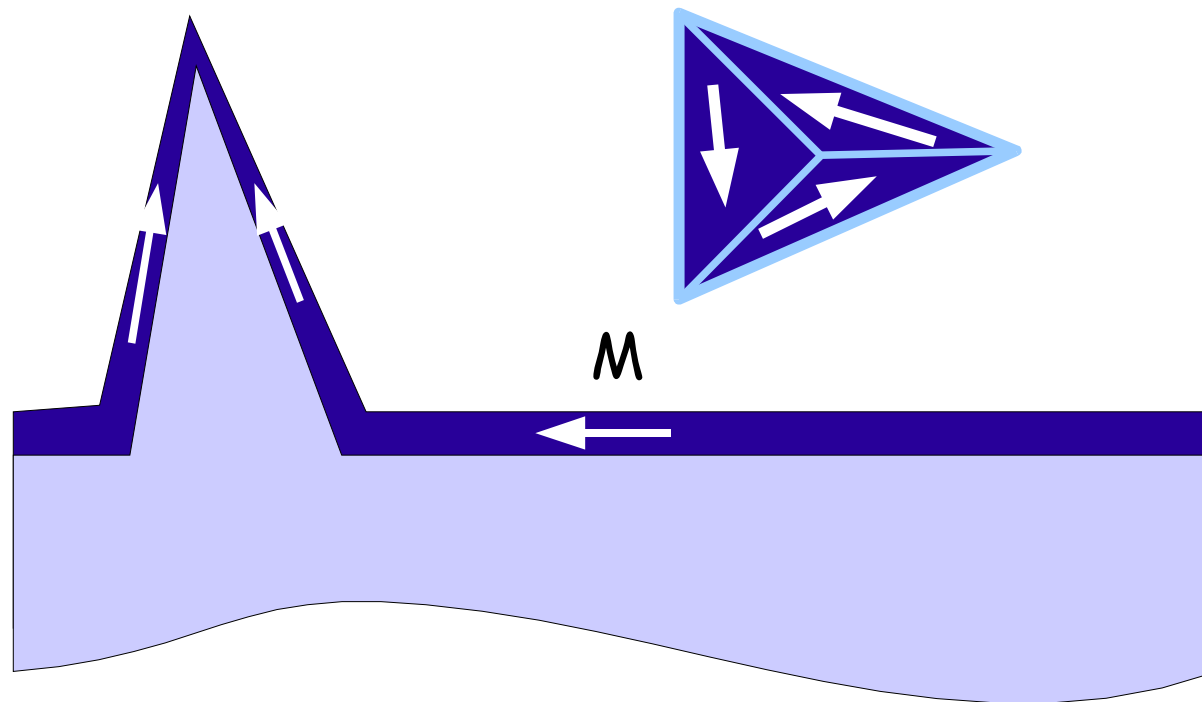
Resolution versus distance



Probes

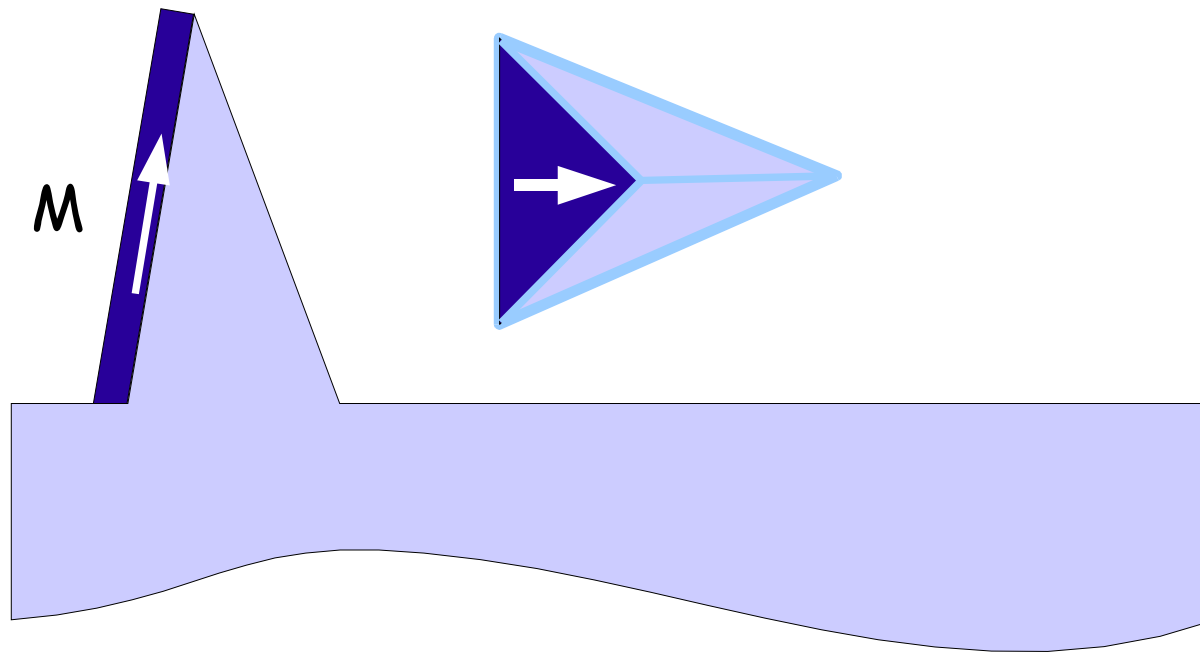


AFM sputtered



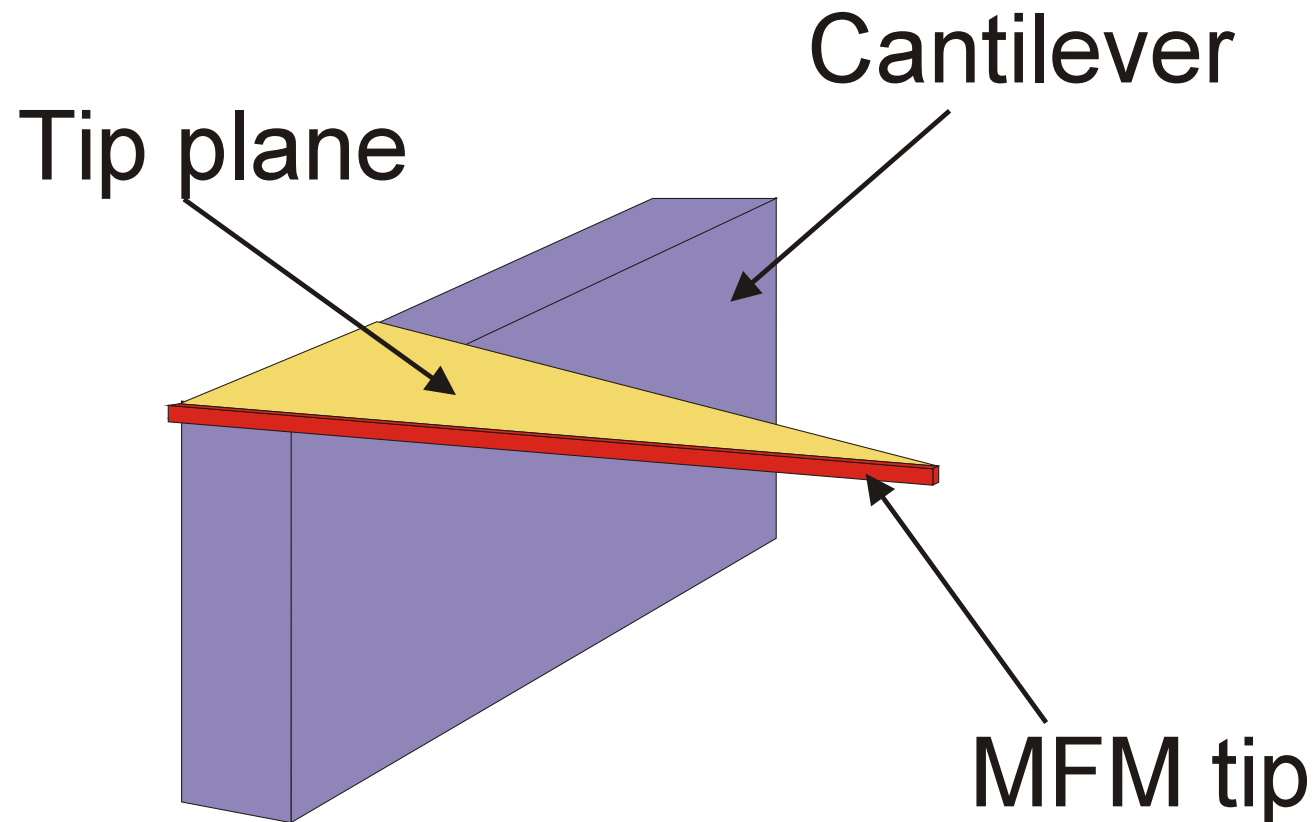
- Sputtered CoCr(X) hard disk materials
- Low/high moment: layer thickness
- Fe, NiFe for low coercivity tips

AFM side coated



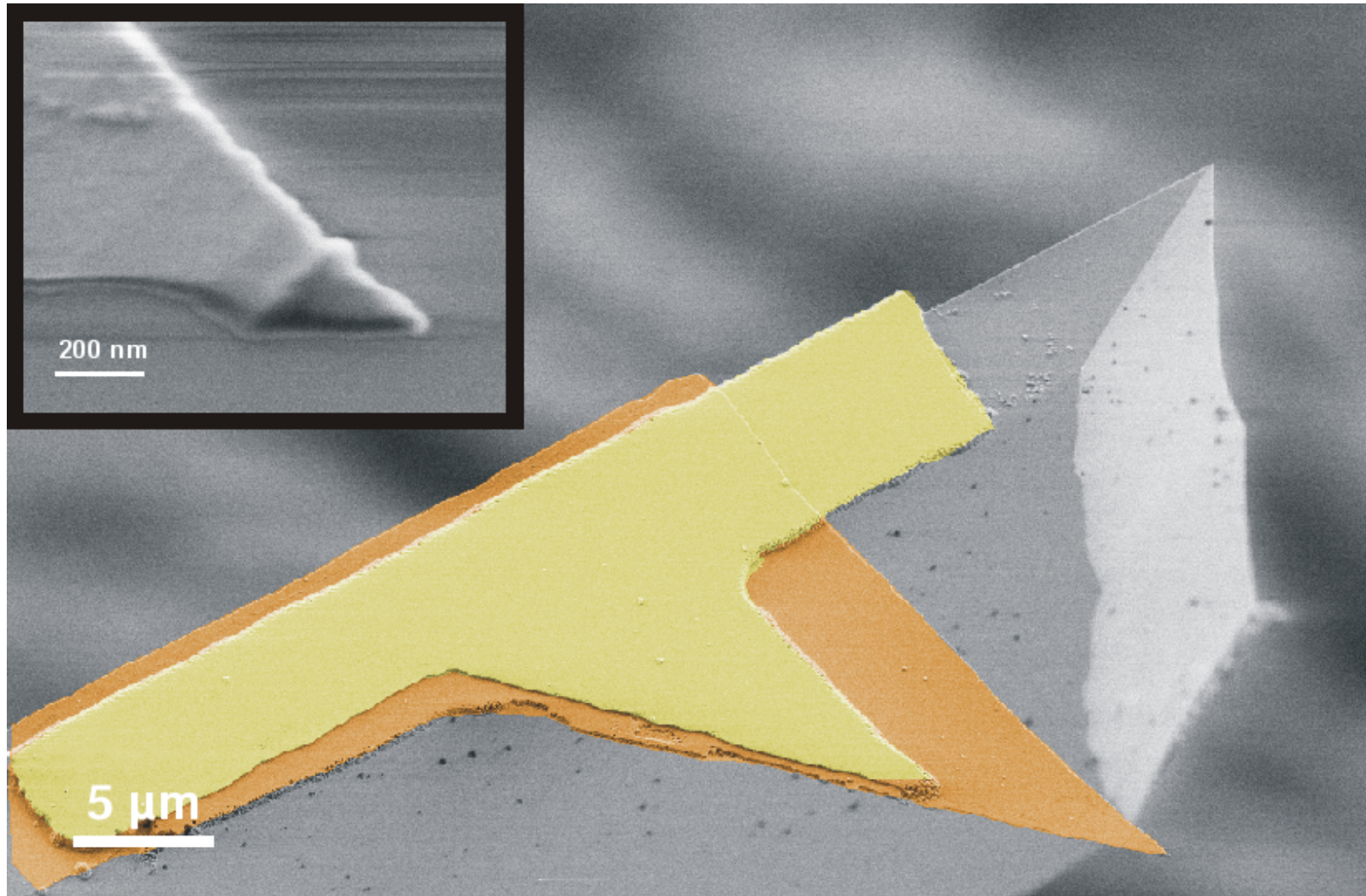
- Co, NiFe evaporated
- Shape anisotropy
- Stable domain structure

CantiClever

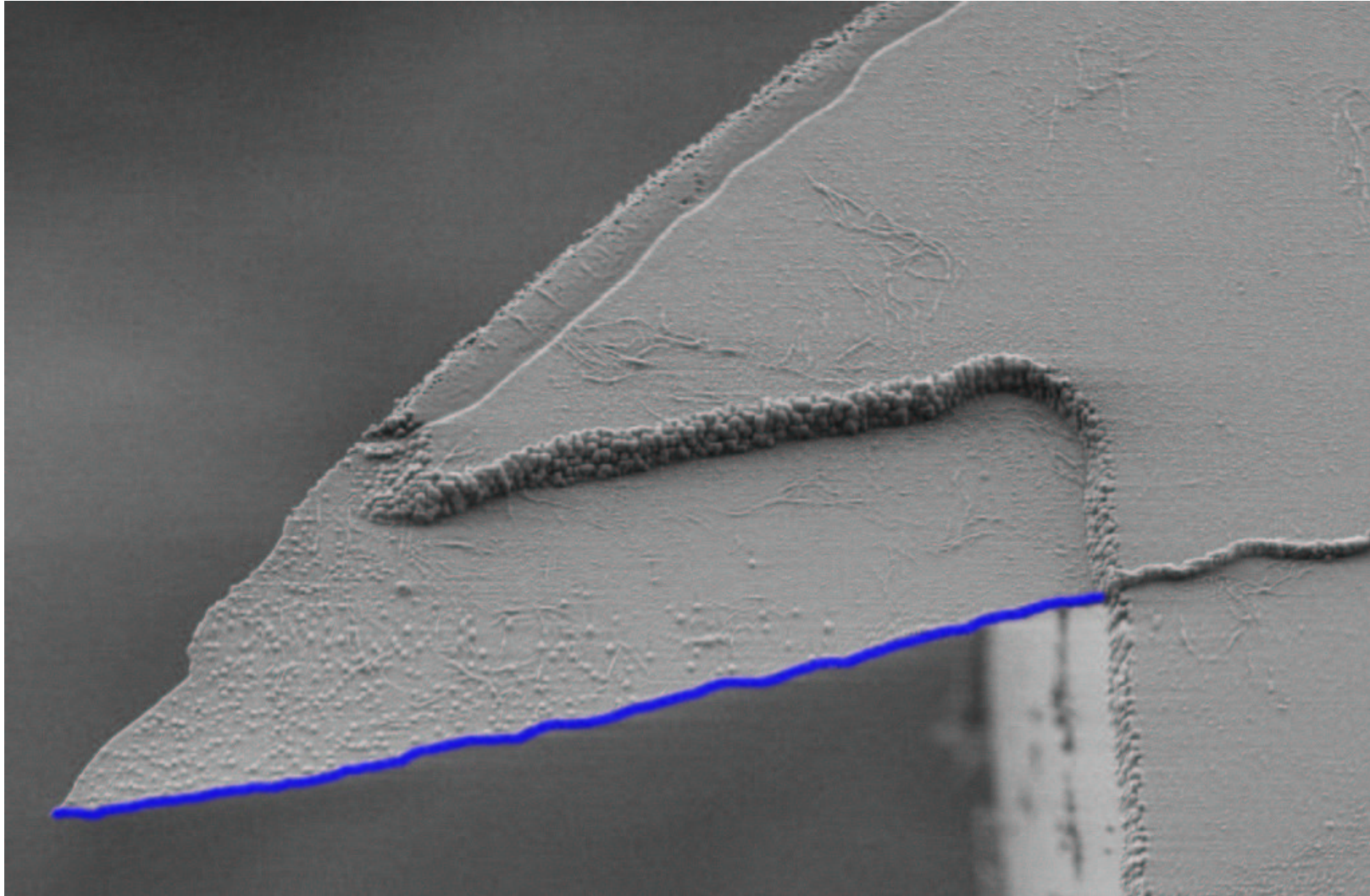


Cross-section determined by layer thicknesses

SEM Images cantilever



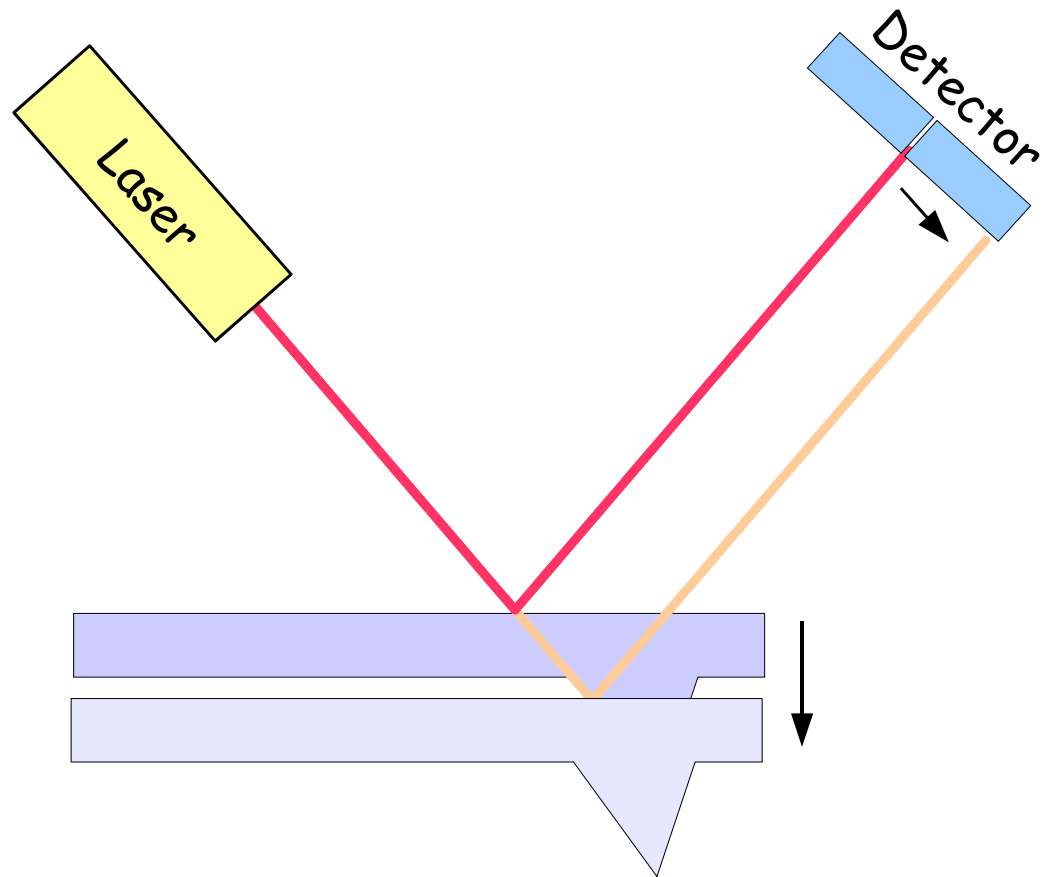
SEM Images tip



Break

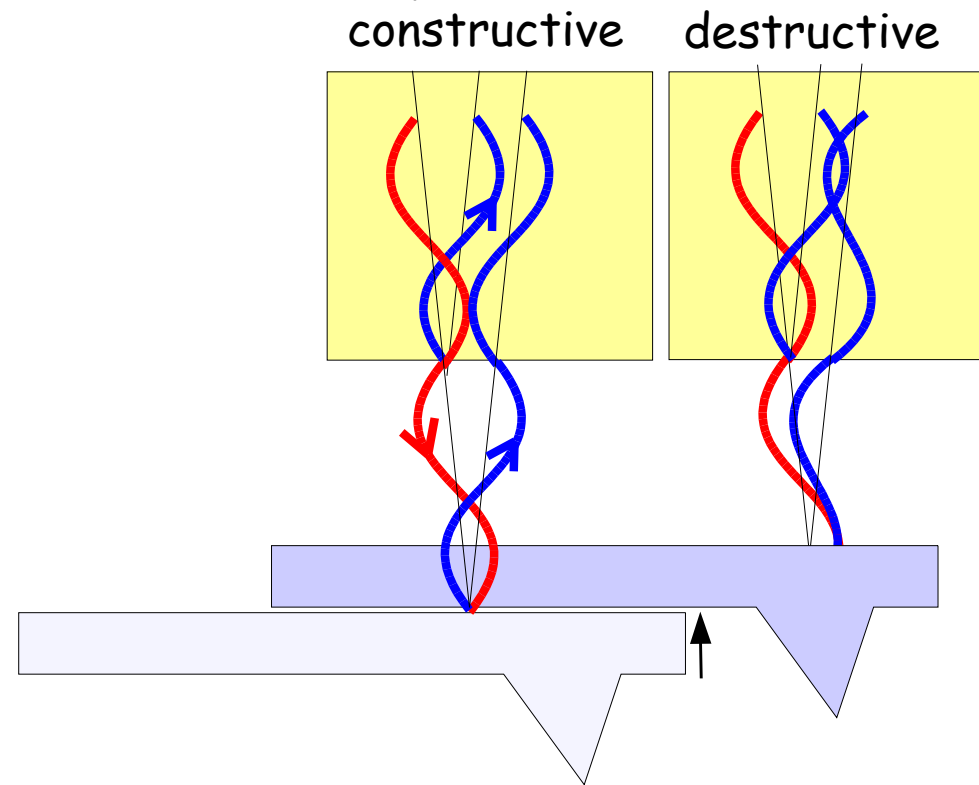


Beam Deflection



- Laser
- LED

Interferometer

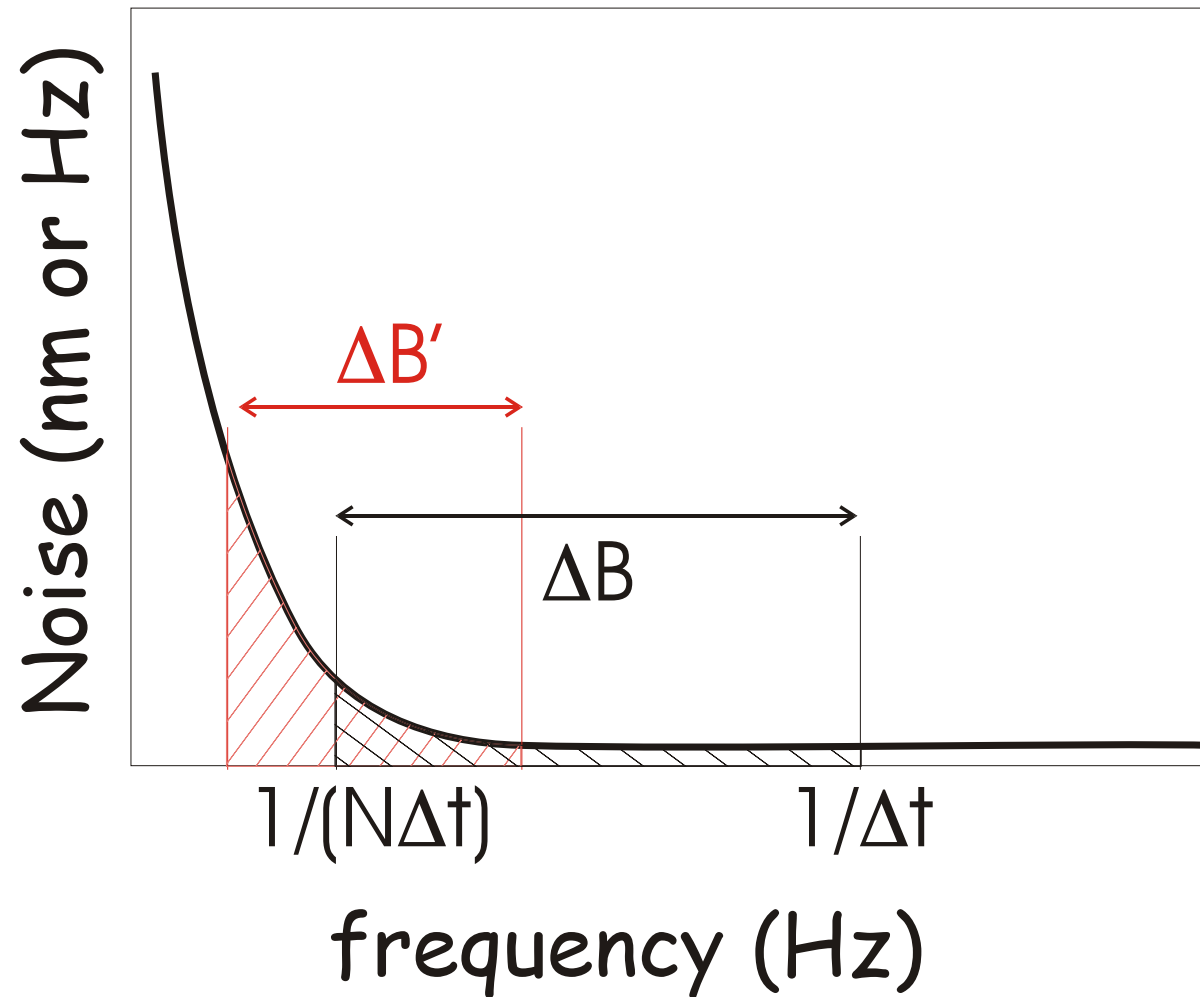


- factor 10 better sensitivity
- difficult to align
- better reflection coatings

Thermal Noise

$$\left(\Delta \left(\frac{\partial F}{\partial z} \right)_{th} \right)_{rms} = \sqrt{\frac{4kTc\Delta B}{\omega_n Q \langle z_{osc}^2 \rangle}}$$

Drift



Vacuum

- Reduce damping, improves Q-factor by 10^5
- Sound isolation
- Remove most of water film (meniscus)

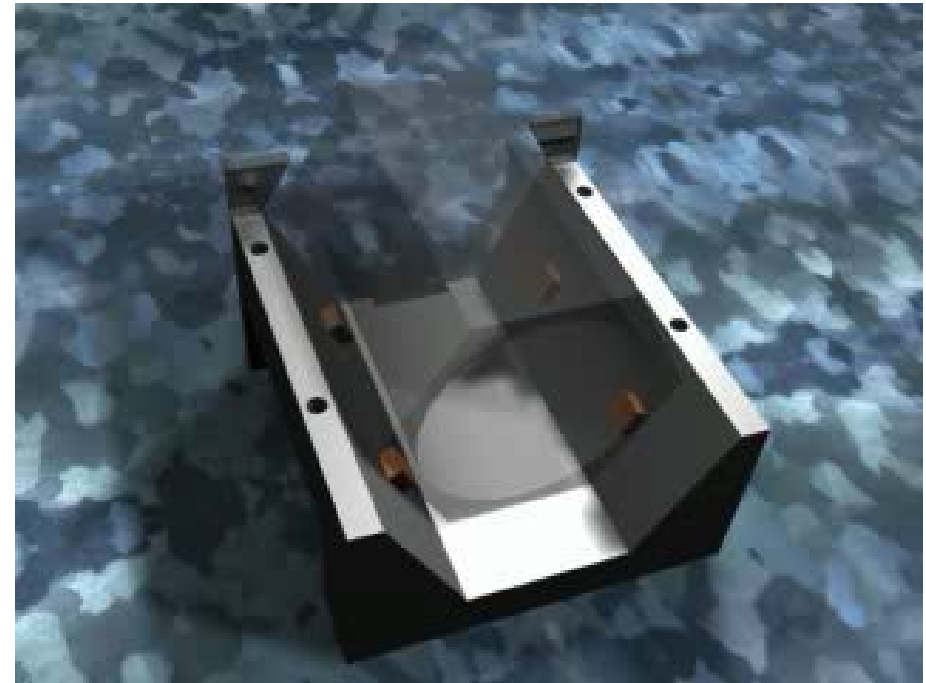
Be careful with break-down (Paschen curve)

Magnetic Field

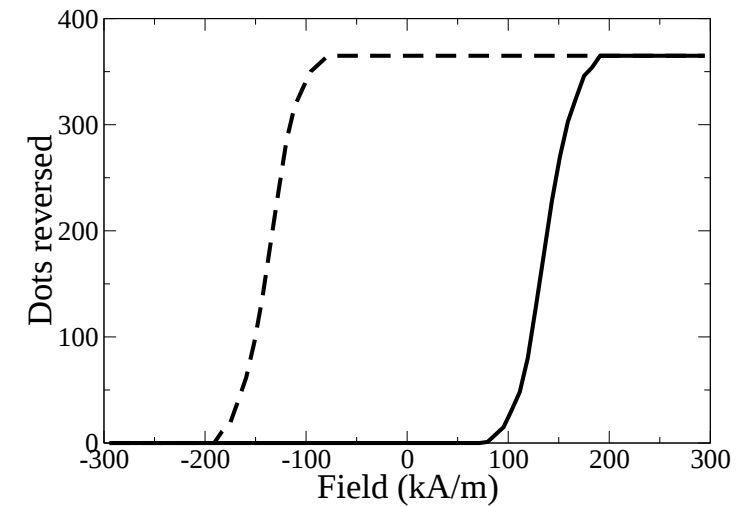
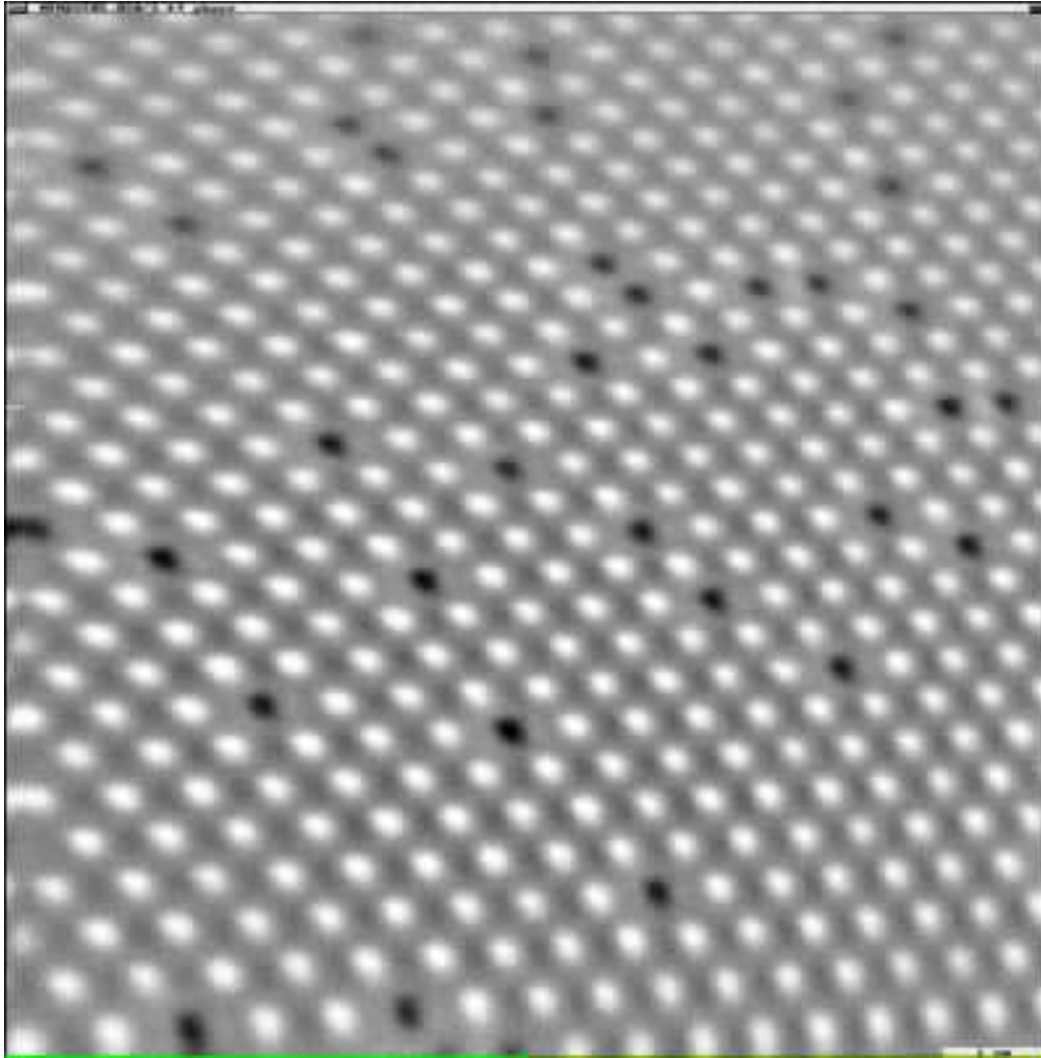
Application of magnetic fields

- On sample
 - Simple
 - Only in-plane
 - Low field
 - Heating
- On microscope
 - Requires very small microscope

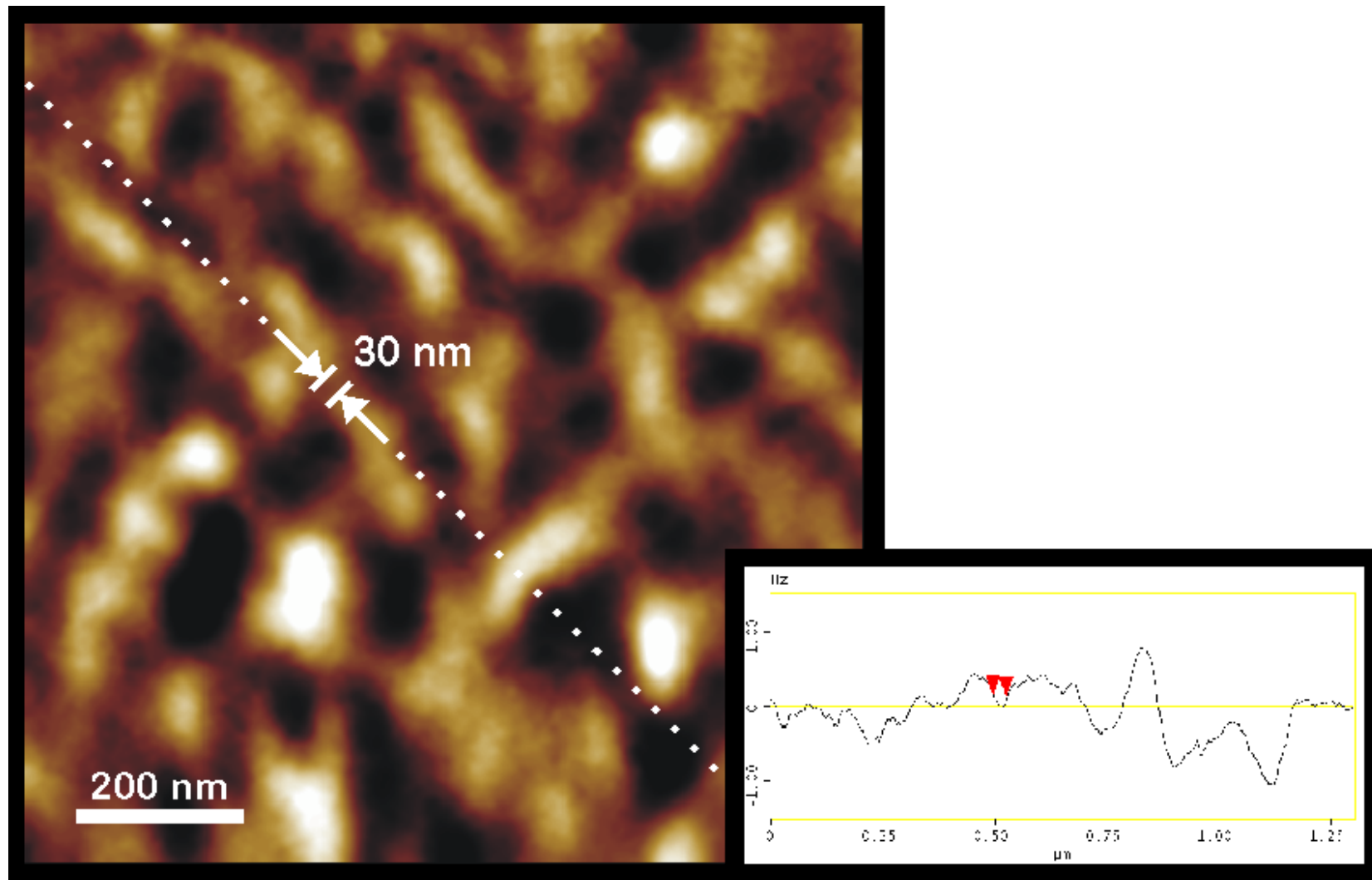
Instrumentation



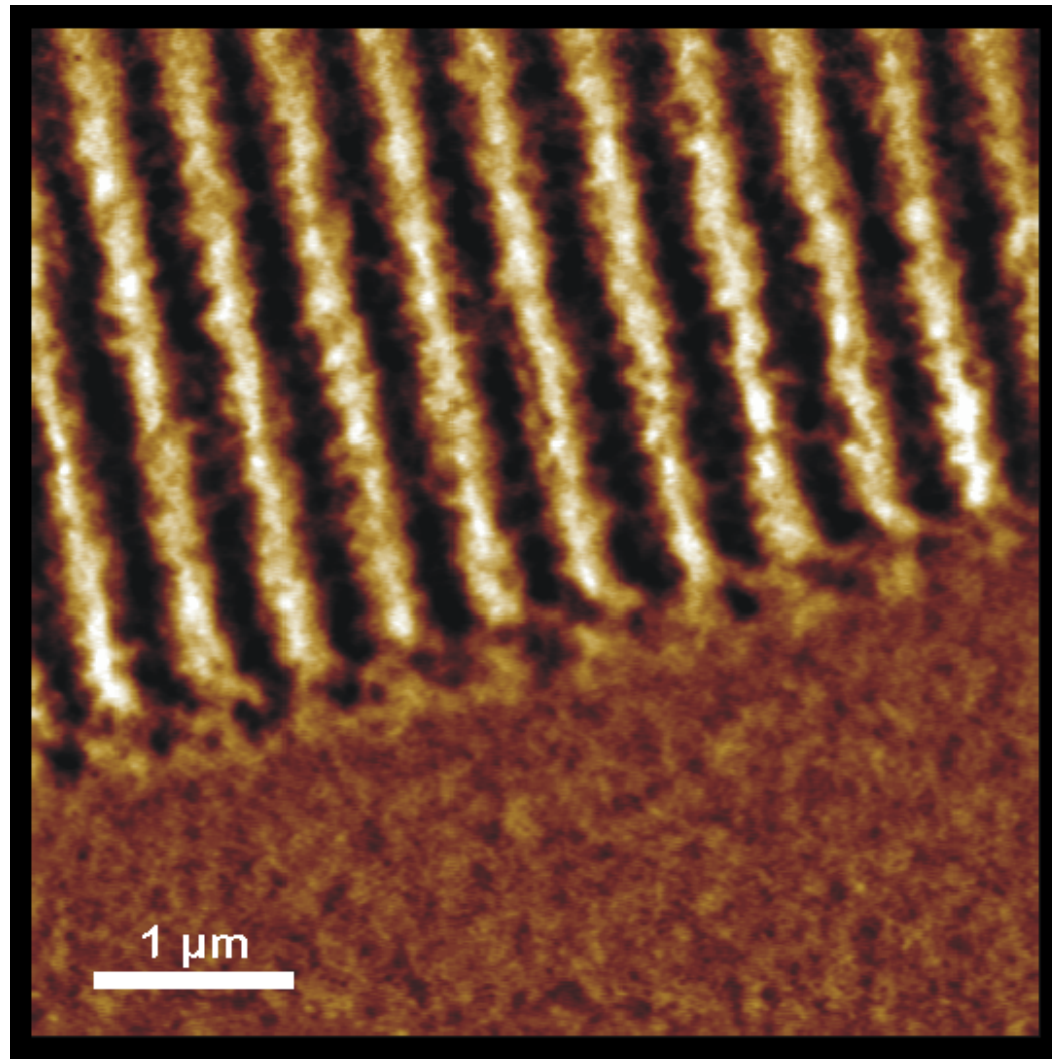
Switching Field Distribution



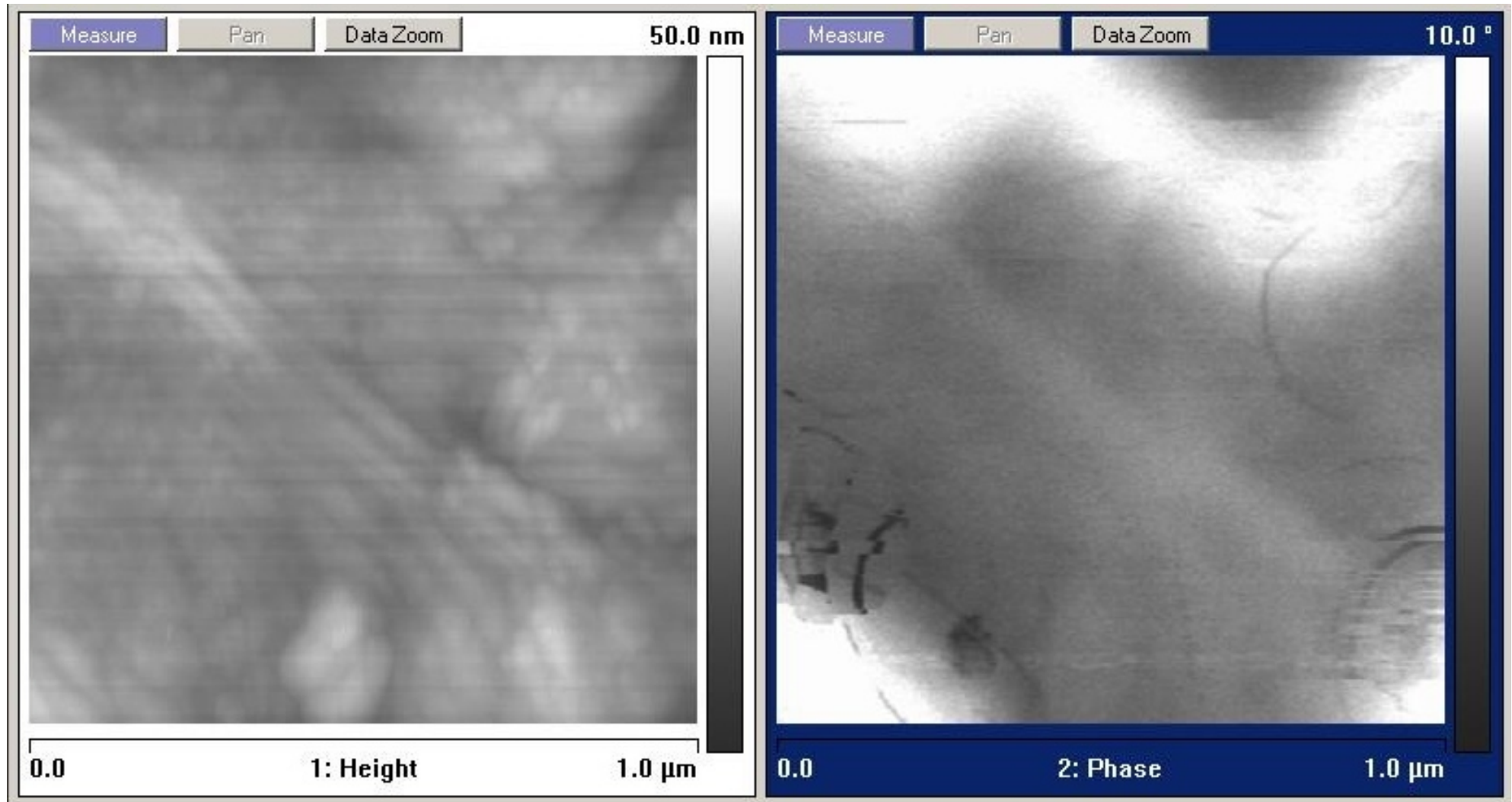
Correct domain image



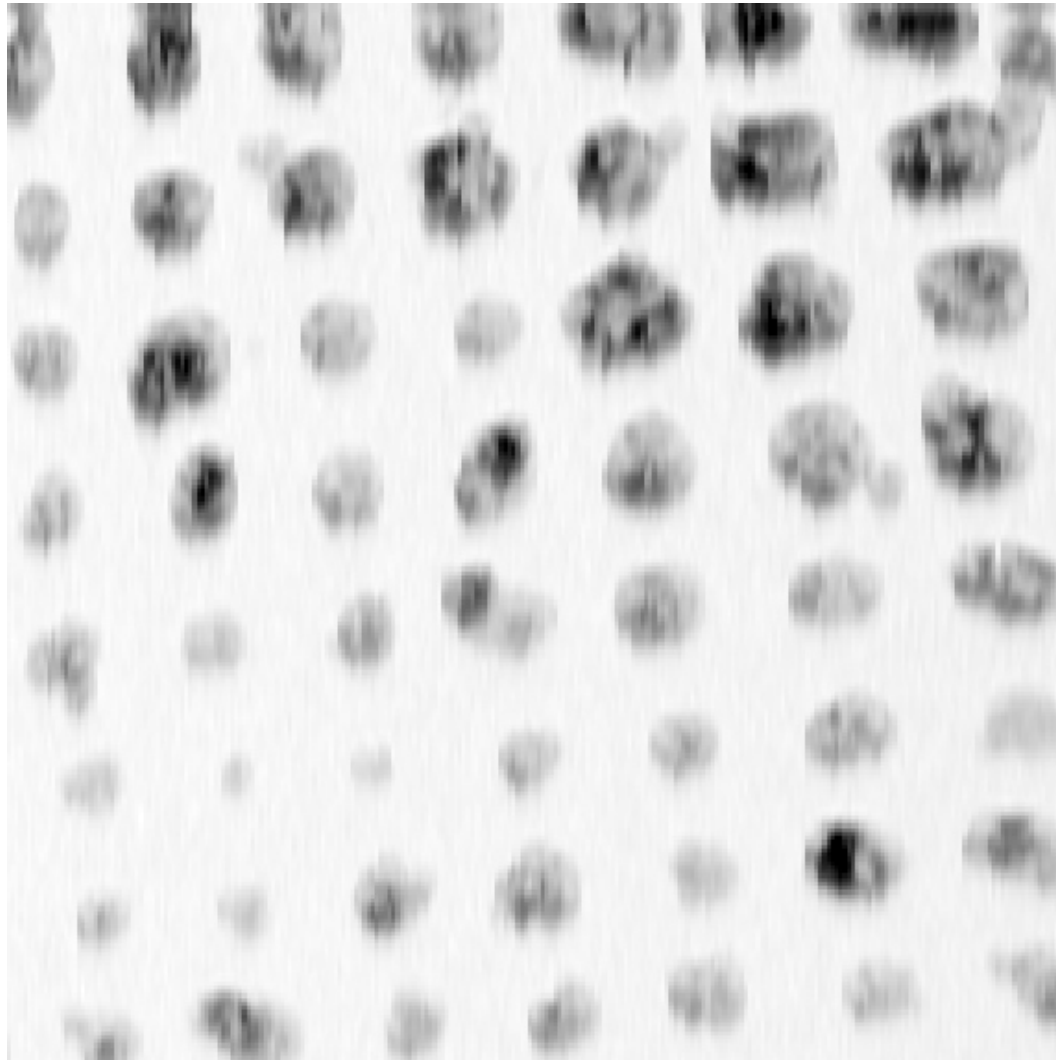
Correct bit pattern



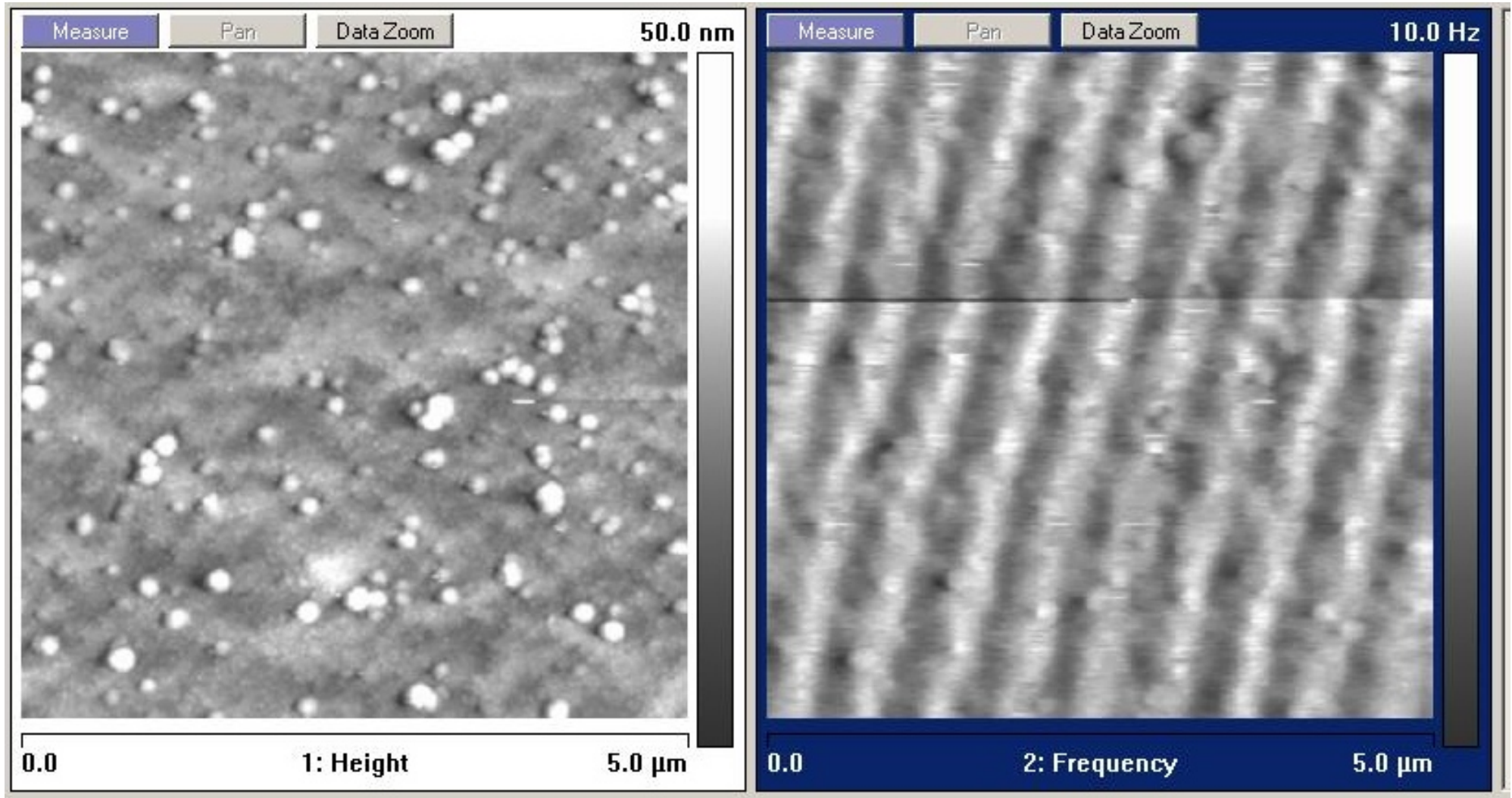
Interference stripes



Topographic contrast



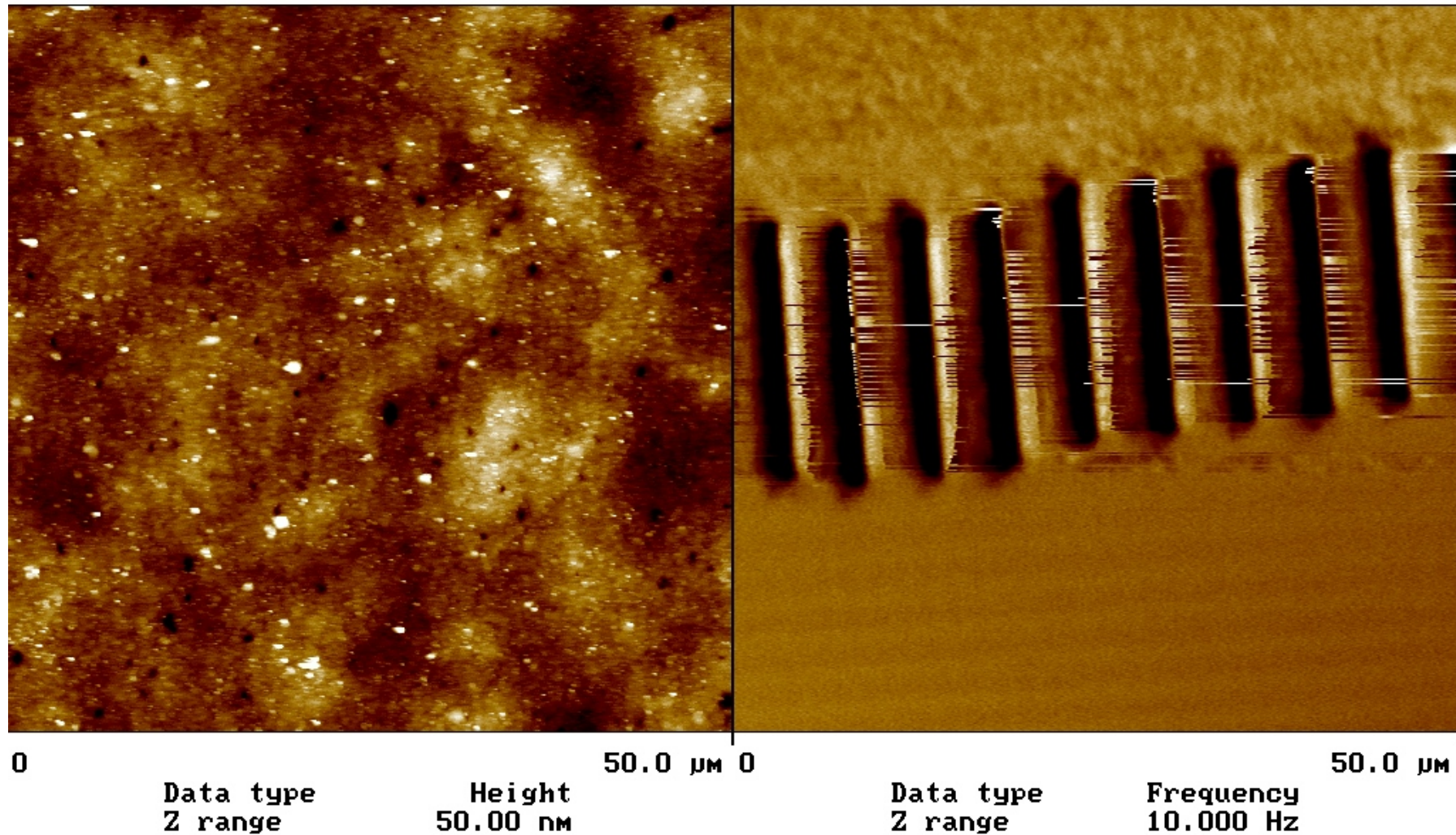
Topographic contrast 2



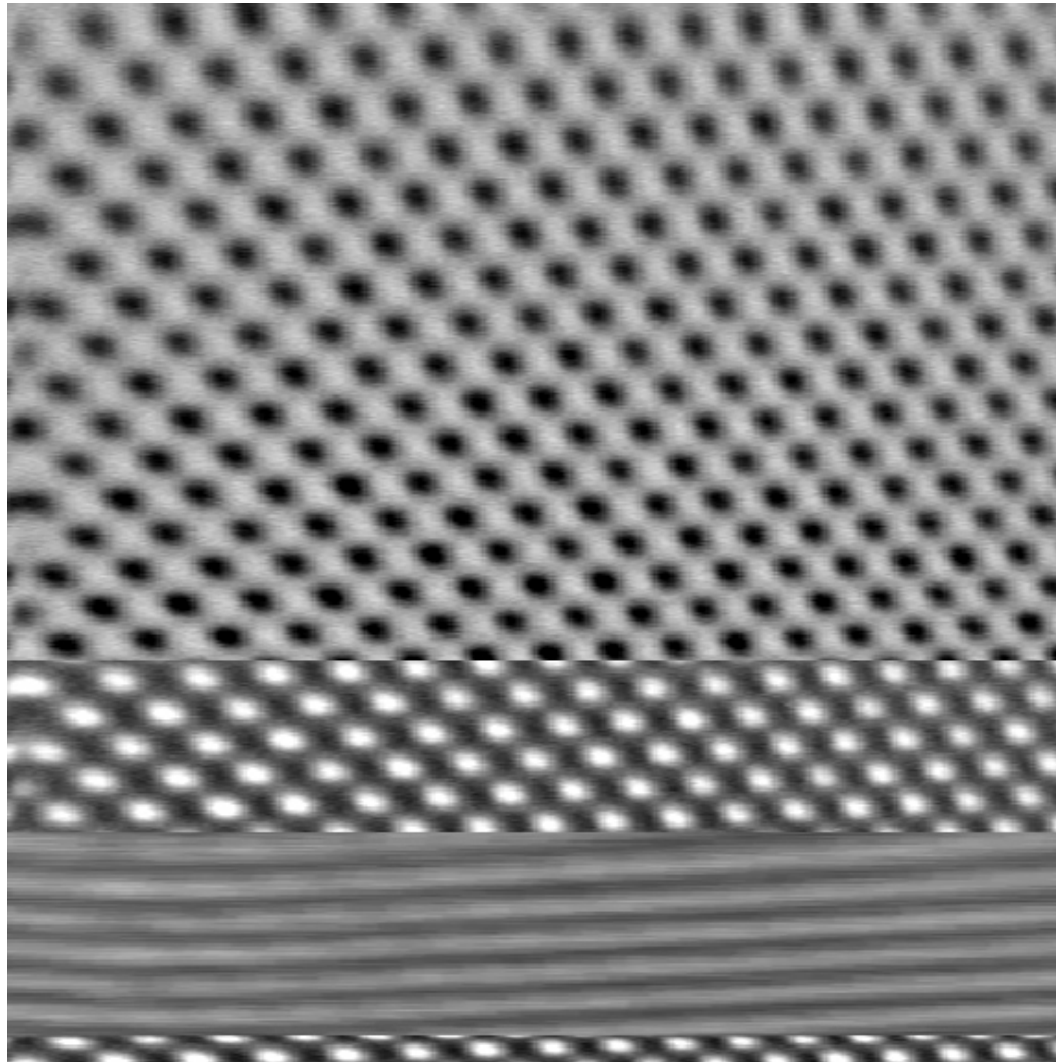
Interaction

- Sample disturbs tip
- Tip disturbs sample
- Reversible/Irreversible

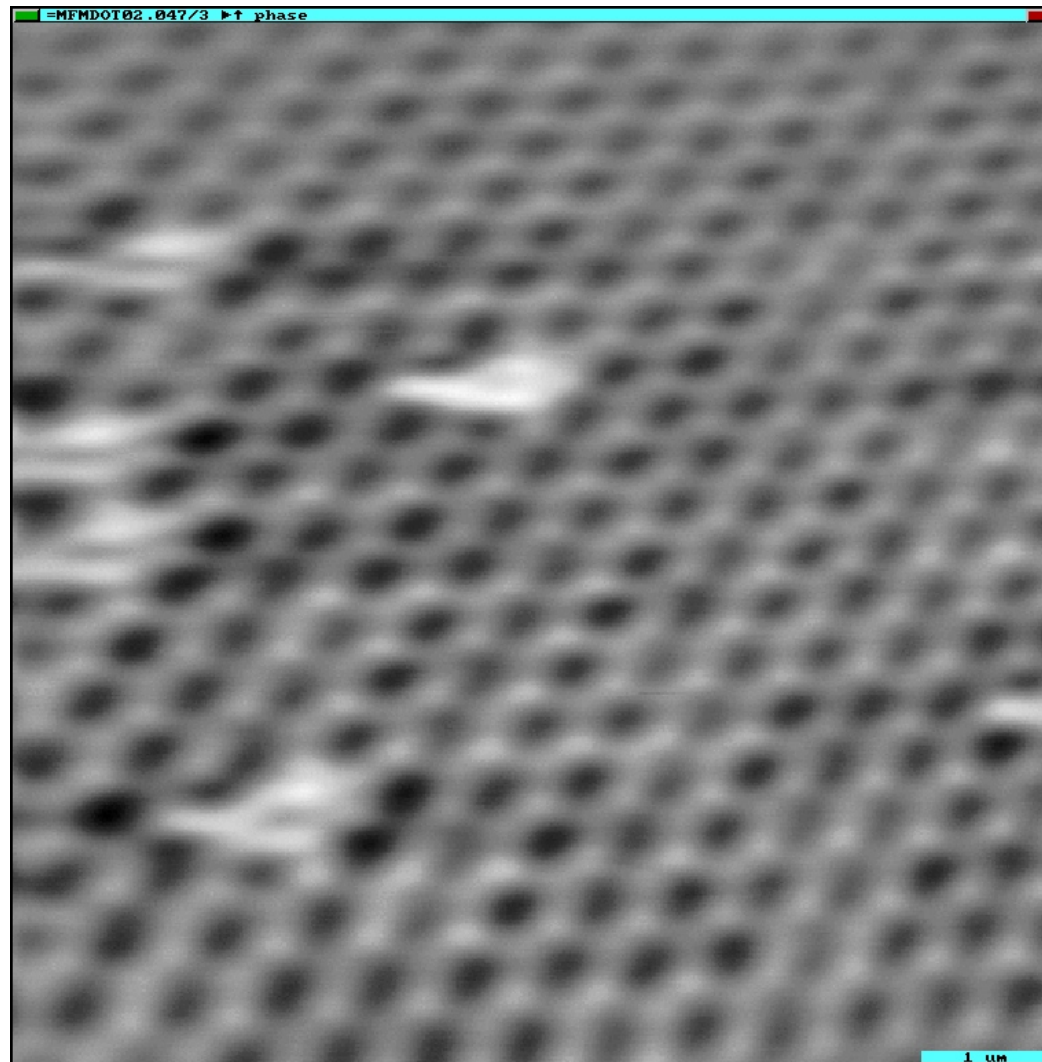
Tip reversal on strong sample



Tip reversal in external field



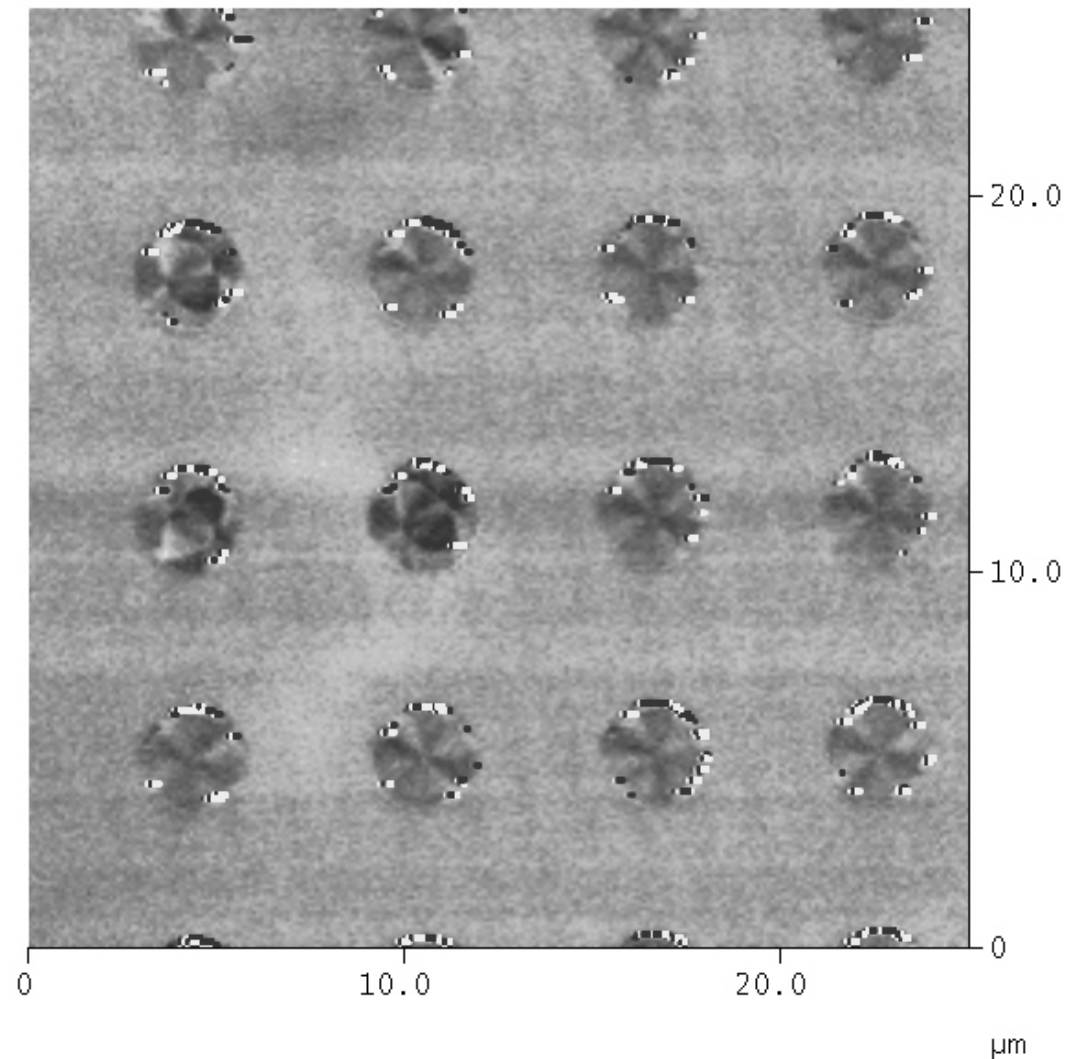
Domain in tip



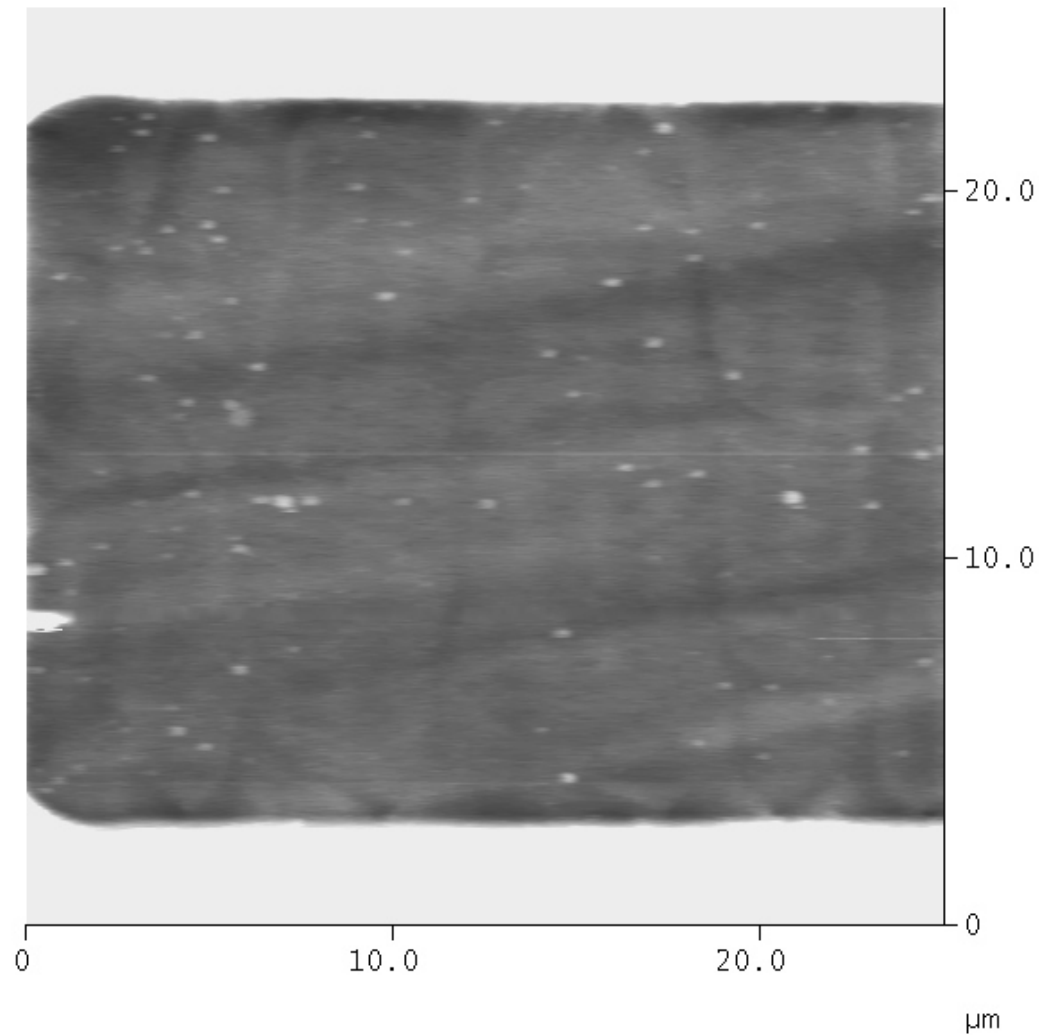
Sample disturbance

- Reversible (susceptibility contrast)
- Irreversible

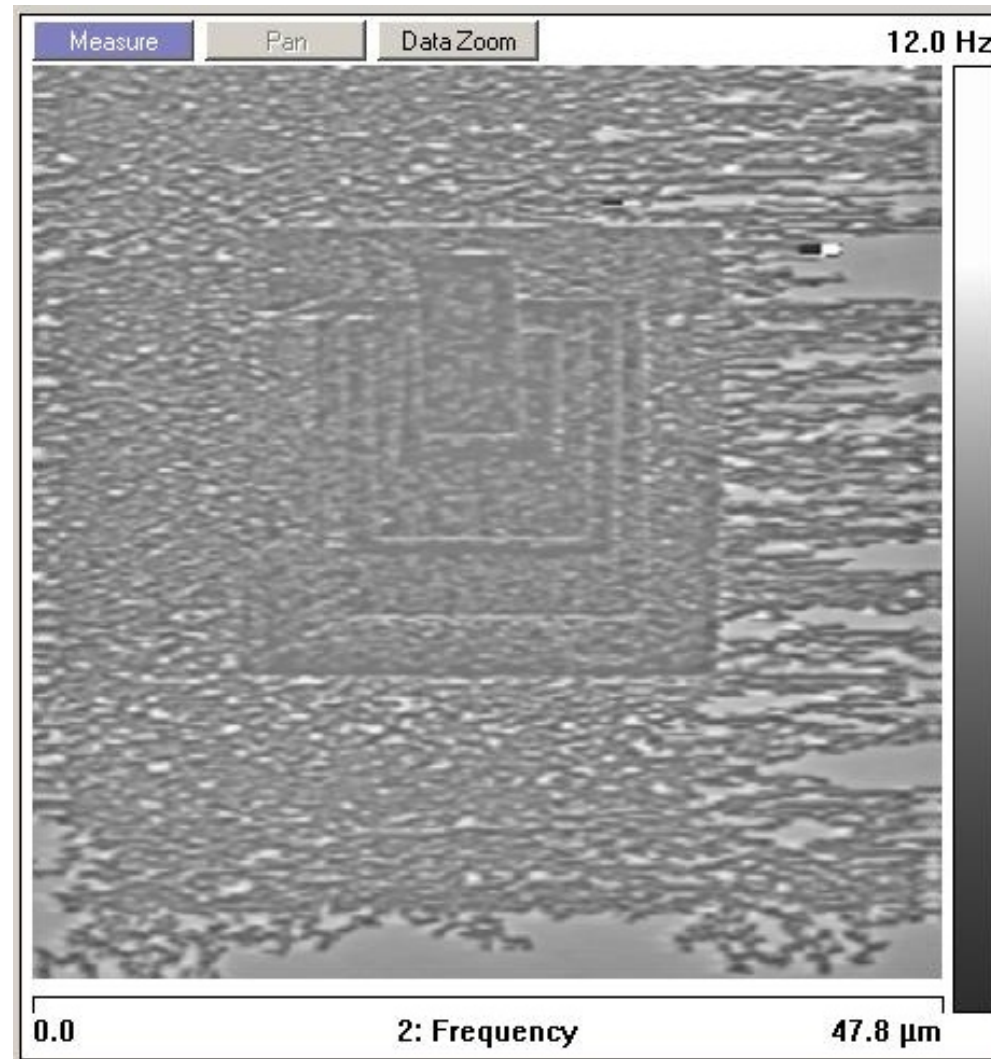
Susceptibility contrast



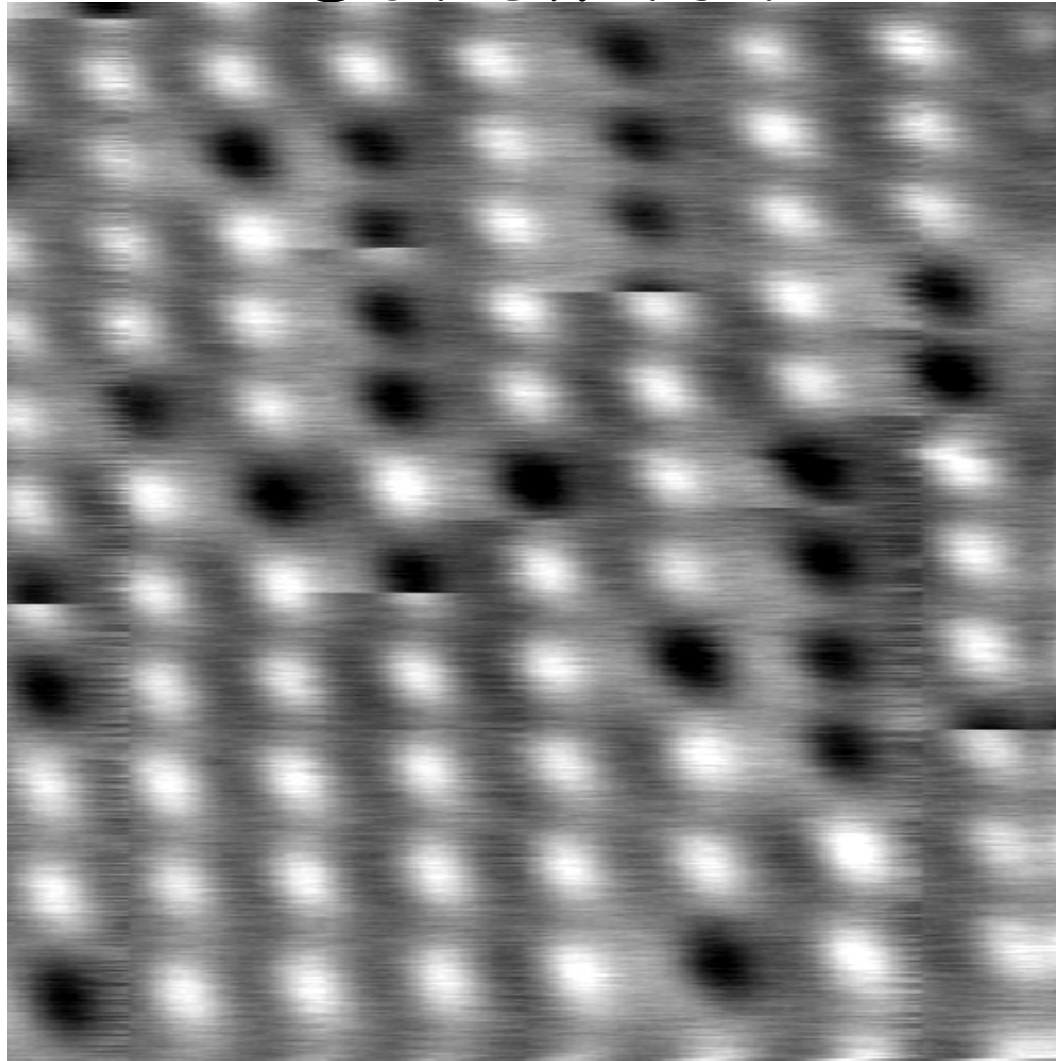
Move domain walls



Disturb sample



Dot switch



Data Storage

Conclusions

- Imaging principle (deflection, phase, frequency)
- Fourier transform for image formation
- Side coated tips
- Noise, bandwidth
- Artefacts (interference, topography)
- Tip/sample interaction